

## IN THE U.S. PATENT AND TRADEMARK OFFICE

Application No.: 10/602,467 PATENT  
 Filing Date: June 23, 2003 Attorney Docket No. 101453-00079 SP#103  
 Inventor(s): **Venkat SELVAMANAICKAM**  
 Group Art Unit: 1762  
 Examiner Name: Not Yet Assigned  
 Customer No.: 026304  
 Title: **APPARATUS FOR HIGH-THROUGHPUT ION BEAM-ASSISTED DEPOSITION (IBAD)**

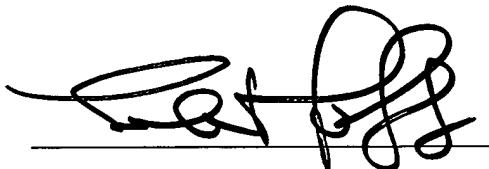
Mail Stop \_\_\_\_\_  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

**REQUEST TO MAKE SPECIAL**

Pursuant to 37 CFR 1.102 applicants hereby request the USPTO to accelerate the processing of the above identified application for patent. The captioned application for patent relates to superconductive materials, processes and techniques for their manufacture and/or use and is within the scope of the Presidential mandate to accelerate prosecution of applications involving superconductivity.

Respectfully submitted,

By: \_\_\_\_\_



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